



Attorney Docket No. 0756-2330

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/894,125

Filed: June 29, 2001

For: CRYSTALLINE SEMICONDUCTOR )  
THIN FILM, METHOD OF )  
FABRICATING THE SAME, )  
SEMICONDUCTOR DEVICE, AND )  
METHOD OF FABRICATING THE )  
SAME )

) Group Art Unit: 2823

) Examiner: B. Kebede

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

4-15-05

Adelle M. Stanger

*Submission  
w/PLP  
5/18/05*

**RESPONSE**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed December 15, 2004, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for One Month Extension of Time*, which extends the period for response to April 15, 2005. Accordingly, the Applicants respectfully submit that this response is being timely filed.

The Applicants note with appreciation the consideration of the Information Disclosure Statements filed on December 19, 2001, April 26, 2002, June 29, 2001, July 5, 2002, July 16, 2002, September 22, 2003, February 17, 2004, March 31, 2004, and October 7, 2004. Regarding the IDS originally filed September 22, 2003 (received by OIPE on September 25, 2003), which was considered by the Examiner with the Official Action mailed December 15, 2004, the Applicants have discovered that the page numbers (pp. 782-785) for the Furue article were inadvertently omitted from the Form PTO-1449. The Applicants respectfully request that the Examiner correct the Form